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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
EITOKU, Atsuro

New York, New York
Date: February 2, 2005

Serial No.: 10/631,797

Group Art Unit: 1746

Date Filed: July 31, 2003

For: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT
METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on July 31, 2003.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

Attorney: James A. Finder
OSTROLENK, FABER, GERB & SOFFEN
1180 Avenue of the Americas
New York, New York 10036-8403
(212) 382-0700